_	0	((((vacuum or void or bubble or "air gap") SAME ((reduce or reduction or reducing) WITH (pressure or heating)) SAME resin)	USPAT; US-PGPUB	2002/05/07 18:13
		and semiconductor) NOT ("transfer mold" or "transfer molding")) and bump		
_	5082	((vacuum or void or bubble or "air gap") WITH resin) SAME (pressure or heating)	USPAT; US-PGPUB	2002/05/09 10:17
_	1	("4,554,126").PN.	USPAT; US-PGPUB	2002/05/07 18:34
_	96466	(resin or encapsulant) SAME (pressure or heating)	USPAT; US-PGPUB	2002/05/09 10:46
_	159	((resin or encapsulant) SAME (pressure or heating)) and (wafer with bump)	USPAT; US-PGPUB	2002/05/09 10:19
-	98	(((resin or encapsulant) SAME (pressure or heating)) and (wafer with bump)) and (void	USPAT; US-PGPUB	2002/05/09 10:21
_	93	or air or bubble or pocket) ((((resin or encapsulant) SAME (pressure or heating)) and (wafer with bump)) and (void or air or bubble or pocket)) and	USPAT; US-PGPUB	2002/05/09 10:21
_	134642	semiconductor (resin or encapsulant) SAME (pressure or	USPAT;	2002/05/09 11:05
		heating or heat)	US-PGPUB	2002/05/09 11:03
_	22489	20010009342.URPN. "hot melt"	USPAT; USPAT; US-PGPUB	2002/05/09 11:05
_	1082	"hot melt" and semiconductor	USPAT; US-PGPUB	2002/05/09 11:06
_	721	("hot melt" and semiconductor) and (resin or encapsulant or encapsulation)	USPAT; US-PGPUB	2002/05/09 11:06
_	7	(("hot melt" and semiconductor) and (resin or encapsulant or encapsulation)) and	USPAT; US-PGPUB	2002/05/09 11:07
-	27	(wafer WITH bump) (US-6352878-\$ or US-6350705-\$ or US-6350668-\$ or US-6281046-\$ or US-6278192-\$ or US-6235842-\$ or	USPAT; US-PGPUB	2002/05/09 13:51
	3	US-6181569-\$ or US-6103552-\$ or US-6063646-\$ or US-6344407-\$ or US-6365057-\$ or US-6307145-\$ or US-5965269-\$ or US-5804126-\$ or US-4554126-\$ or US-6225205-\$ or US-6114753-\$).did. or (US-20020027257-\$ or US-2010020737-\$ or US-20020001688-\$ or US-20020000658-\$ or US-20020030258-\$ or US-20020031868-\$ or US-20020030258-\$ or US-2002003058-\$).did. ((US-6352878-\$ or US-6350705-\$ or US-635068-\$ or US-6281046-\$ or US-635068-\$ or US-6235842-\$ or US-6181569-\$ or US-63552-\$ or US-6063646-\$ or US-6365057-\$ or US-6365057-\$ or US-6365057-\$ or US-6365057-\$ or US-6365057-\$ or US-6365057-\$ or US-6307145-\$ or	USPAT; US-PGPUB	2002/05/09 13:55
		US-5965269-\$ or US-5804126-\$ or US-4554126-\$ or US-6225205-\$ or US-6114753-\$).did. or (US-20020027257-\$ or US-20010020737-\$ or US-20020001688-\$ or US-2002000658-\$ or US-20020031868-\$ or US-20020031868-\$ or US-2002003258-\$ or US-20020025667-\$ or US-20010009342-\$ or US-20010003058-\$).did.) and (void with pressure)		
-	11	(void with pressure) and (semiconductor) and (wafer with bump)	USPAT; US-PGPUB	2002/05/09 13:58
-	36	((void or bubble) SAME pressure) and (semiconductor) and (wafer with bump)	USPAT; US-PGPUB	2002/05/09 14:18
-	49	(void SAME vacuum) and (semiconductor) and (wafer with bump)	USPAT; US-PGPUB	2002/05/09 14:14
				<u> </u>

	46	((void SAME vacuum) and (semiconductor)	USPAT;	2002/05/09 14:21
-	40	and (wafer with bump)	US-PGPUB	2002,00,03 1.121
) NOT (((void or bubble) SAME pressure)	05 10105	
		and (semiconductor) and (wafer with bump)		
-)		
-	34585	resin WITH pressure	USPAT;	2002/05/09 14:23
1		Cool was passed	US-PGPUB	
_	1136	(resin WITH pressure) and wafer	USPAT;	2002/05/09 14:21
		, and an arrangement of the second of the se	US-PGPUB	
_	751	((resin WITH pressure) and wafer) and	USPAT;	2002/05/09 14:22
	ļ	semiconductor	US-PGPUB	
-	0	"L751" and (encapsulant or encapsulating	USPAT;	2002/05/09 14:22
	1	or filler or protective)	US-PGPUB	
-	374		USPAT;	2002/05/09 14:22
		semiconductor) and (encapsulant or	US-PGPUB	
		encapsulating or filler or protective)		
-	62	((((resin WITH pressure) and wafer) and	USPAT;	2002/05/09 16:08
		semiconductor) and (encapsulant or	US-PGPUB	
		encapsulating or filler or protective))		
		and void		†
-	1	("4,900,485").PN.	USPAT;	2002/05/09 14:27
			US-PGPUB	
-	3	(("6126532") or ("6225205") or	USPAT;	2002/05/09 16:17
		("5300735")).PN.	US-PGPUB	
-	2	(("6126428") or ("6214649")).PN.	USPAT;	2002/05/09 16:41
	ļ		US-PGPUB	
-	1	("6214649").PN.	USPAT;	2002/05/09 17:18
	ļ		US-PGPUB	
-	1	("5926694").PN.	USPAT;	2002/05/09 17:19
1			US-PGPUB	
-	6119		USPAT;	2002/05/09 17:49
		or "air pocket" or hole) SAME pressure	US-PGPUB	
-	1920		USPAT;	2002/05/09 17:50
	}	(void or "air pocket" or hole) SAME	US-PGPUB	
		pressure		
) and (atmosphere or atmospheric or		1
		subatmospheric)		
-	53		USPAT;	2002/05/09 17:50
		(void or "air pocket" or hole) SAME	US-PGPUB	
		pressure		
) and (atmosphere or atmospheric or		
		subatmospheric)) and (wafer and packaging)		